



PATENT
1794-0147P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KUMAGAI et al. Conf.: 2509
Appl. No.: 10/058,086 Group: 2881
Filed: January 29, 2002 Examiner: Erin Gill
For: METHOD FOR LASER COOLING OF ATOMS AND APPARATUS
THEREFORE (*as amended*)

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 7, 2004

Sir:

In reply to the Office Action dated February 24, 2004, the due date for response having been petitioned to be extended one (1) month to June 24, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

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